

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application of:

Sung-Hwa LEE et al.

Application No.: 10/539,552

Confirmation No.: 2680

Filed: June 16, 2005

Art Unit: 3742

For: COOLING STRUCTURE FOR PLASMA
LIGHTING SYSTEM

Examiner: Q. T. Van

REPLY UNDER § 1.116

MS AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENTS

In reply to the Office Action dated May 25, 2010, the following remarks are respectfully submitted in connection with the above-identified application.